

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2624

00684.003585

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: C. G. Daley
Takenobu KOBAYASHI et al.)	
	:	Group Art Unit: 2624
Application No.: 10/777,192)	
	:	Confirmation No.: 7532
Filed: February 13, 2004)	
	:	October 23, 2008
For: SURFACE POSITION MEASURING METHOD)		
AND APPARATUS	:	

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Office Action dated July 23, 2008, please amend the above-identified application as follows, pursuant to 37 CFR 1.116: